

2812  
PATENT

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Case Docket No. ASMMC.036AUS  
Date: March 1, 2002



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : SOPHIE et al.  
Appl. No. : 09/975,466  
Filed : October 9, 2001  
For : IN SITU REDUCTION OF  
COPPER OXIDE PRIOR TO  
SILICON CARBIDE  
DEPOSITION  
Examiner : Unknown  
Group Art Unit : 2812

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Dear Sir:

Enclosed for filing in the above-identified application are:

- (X) A Supplemental Information Disclosure Statement.
- (X) A Form PTO-1449 with five (5) references.
- (X) The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment, to Account No. 11-1410.
- (X) Return prepaid postcard.

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